



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#51esson P/A
G Ford
5/28/00

Application Serial No. 09/212,726
Filing Date December 15, 1998
3 Inventor Klaus F. Schuegraf
Assignee Micron Technology, Inc.
4 Group Art Unit 2812
Examiner Not Known
5 Attorney's Docket No. MI22-1098
Title: Semiconductor Processing Methods of Chemical Vapor
6 Depositing SiO₂ on a Substrate

7 Assistant Commissioner for Patents
8 Washington, D.C. 20231

9 Sir:

ASSOCIATE POWER OF ATTORNEY

11 Please recognize Frederick M. Fliegel, Reg. No. 36,138; D. Brent
12 Kenady, Reg. No. 40,045; James E. Lake, Reg. No. 44,854; and Bernard
13 Berman, Reg. No. 37,279; whose post office address is 601 W. First
14 Avenue, Suite 1300, Spokane, Washington 99201-3828, as associate attorneys
15 or agents in the above-entitled application.

16
17 Date: 5/2/00


David G. Latwesen, Ph.D.

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